

06-26-06

AF ZM

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as Express Mail, Airbill No. EV781674429US, in an envelope addressed to: MS AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: June 23, 2006

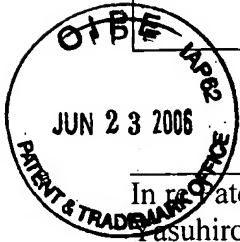
Signature:

(Marcos Jimenez)

Docket No.: 199372005100

Client reference: 141824US

(PATENT)



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Masuhiro CHONO et al.

Confirmation No.: 9511

Application No.: 10/602,041

Examiner: Jeffrie Robert Lund

Filed: June 23, 2003

Art Unit: 1763

For: SUBSTRATE PROCESSING SYSTEM AND
SUBSTRATE PROCESSING METHOD

REPLY AND REQUEST FOR RECONSIDERATION

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated February 23, 2006, for which a response was due on May 23, 2006, and for which a one-month extension of time is also requested to extend the time for response from May 23, 2006, to June 23, 2006, please consider the following:

There are no amendments to the specification, drawings or claims.

A listing of claims begins on page 2.

Remarks begin on page 6.